

Notice of References Cited

Application/Control No.

09/870,242

Applicant(s)/Patent Under
Reexamination
GOELA ET AL.

Examiner

Brian P. Egan

Art Unit

1772

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,904,778	05-1999	Lu et al.	118/723
	B	US-4,999,228	03-1991	Matsumoto et al.	428/34.4
	C	US-5,443,649	08-1995	Sibley	118/728
	D	US-			
	E	US-			
	F	US-			
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Low-Cost Fabrication of Large Silicon Carbide/Silicon Carbide Composite Structures (last visited Dec. 18, 2002) at http://es.epa.gov/ncer_abstracts/sbir/other/hazsolid/miller2.html .
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	W	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.